



PATENT  
8017-1094

IN THE U.S. PATENT AND TRADEMARK OFFICE

In re application of

Toshiji TAIJI et al.

Conf. 2404

Application No. 10/616,914

Group 1765

Filed July 11, 2003

Examiner L. Umez Eronini

SLURRY FOR CHEMICAL MECHANICAL POLISHING

**AMENDMENT**

Assistant Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

October 21, 2005

Sir:

In response to the Official Action mailed June 2, 2005,  
please amend the above-identified application as follows:

**Amendments to the Claims** are reflected in the listing  
of claims which begins on page 2 of this paper.

**Remarks** begin on page 4 of this paper.